

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	9	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 exhaust near20 chamber) and ((automatic or automatically or automate or automation or automated) near10 (sampling or sample or sampler or sampled or specimen))	US-PGPUB	OR	ON	2005/11/13 23:47
L2	3	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 exhaust near20 chamber) and ((automatic or automatically or automate or automation or automated) near10 (sampling or sample or sampler or sampled or specimen))	USPAT	OR	ON	2005/11/13 23:48
L3	6	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 signal near20 chamber) and ((sampling or sample or sampler or sampled or specimen) near15 exhaust near15 chamber)	US-PGPUB	OR	ON	2005/11/13 23:49
L4	11	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 signal near20 chamber) and ((sampling or sample or sampler or sampled or specimen) near15 exhaust near15 chamber)	USPAT	OR	ON	2005/11/13 23:49

L5	1	(wafer near (processing or processed pr processor or processor)) and (chamber near10 exhaust) and ((particle near (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) near15 exhaust) and ((particle with (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) with ((sampling or sample or sampler or sampled or specimen) near10 exhaust))	US-PGPUB	OR	ON	2005/11/13 23:50
L6	0	(wafer near (processing or processed pr processor or processor)) and (chamber near10 exhaust) and ((particle near (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) near15 exhaust) and ((particle with (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) with ((sampling or sample or sampler or sampled or specimen) near10 exhaust))	USPAT	OR	ON	2005/11/13 23:50
L7	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n001/22 or g01n001/40).ipc. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57).ccls.)	US-PGPUB	OR	ON	2005/11/14 00:01
L8	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n001/22 or g01n001/40).ipc. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57).ccls.)	USPAT	OR	ON	2005/11/13 23:51
L9	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and g01n001/00.ipc.	US-PGPUB	OR	ON	2005/11/13 23:51
L10	2	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and g01n001/00.ipc.	USPAT	OR	ON	2005/11/13 23:52

L11	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n015/00 or g01n015/06).ipc. or (73/28.01 or 73/865.5 or 73/28.04).ccls.)	US-PGPUB	OR	ON	2005/11/13 23:52
L12	2	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n015/00 or g01n015/06).ipc. or (73/28.01 or 73/865.5 or 73/28.04).ccls.)	USPAT	OR	ON	2005/11/13 23:52
L13	9	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 exhaust near20 chamber) and ((automatic or automatically or automate or automation or automated) near10 (sampling or sample or sampler or sampled or specimen))	US-PGPUB	OR	ON	2005/11/13 23:52
L14	6	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 signal near20 chamber) and ((sampling or sample or sampler or sampled or specimen) near15 exhaust near15 chamber)	US-PGPUB	OR	ON	2005/11/13 23:53
L15	0	(wafer near (processing or processed pr processor or processor)) and (chamber near10 exhaust) and ((particle near (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) near15 exhaust) and ((particle with (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) with ((sampling or sample or sampler or sampled or specimen) near10 exhaust))	USPAT	OR	ON	2005/11/13 23:53

L16	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n001/22 or g01n001/40).ipc. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57).ccls.)	US-PGPUB	OR	ON	2005/11/13 23:53
L17	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and g01n001/00.ipc.	US-PGPUB	OR	ON	2005/11/13 23:53
L18	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n015/00 or g01n015/06).ipc. or (73/28.01 or 73/865.5 or 73/28.04).ccls.)	US-PGPUB	OR	ON	2005/11/13 23:54
L19	3	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 exhaust near20 chamber) and ((automatic or automatically or automate or automation or automated) near10 (sampling or sample or sampler or sampled or specimen))	USPAT	OR	ON	2005/11/13 23:54
L20	11	(fabrication or fabricating or fabricater or fabricator or fabricate or fabricated) and ((monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or testing or tested or tester or test or detect or detected or detection or detecting or detector or detector) near20 signal near20 chamber) and ((sampling or sample or sampler or sampled or specimen) near15 exhaust near15 chamber)	USPAT	OR	ON	2005/11/13 23:54

L21	0	(wafer near (processing or processed pr processor or processor)) and (chamber near10 exhaust) and ((particle near (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) near15 exhaust) and ((particle with (monitor or monitored or monitoring or analyze or analyzed or analyzing or analyzer or analyzer or sensor or sensing or sensed or sense or detect or detected or detection or detecting or detector or detector)) with ((sampling or sample or sampler or sampled or specimen) near10 exhaust))	USPAT	OR	ON	2005/11/13 23:54
L22	0	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n001/22 or g01n001/40).ipc. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57).ccls.)	USPAT	OR	ON	2005/11/13 23:55
L23	2	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and g01n001/00.ipc.	USPAT	OR	ON	2005/11/13 23:55
L24	2	(h01l021/66.ipc. or (438/5 or 438/14).ccls.) and ((g01n015/00 or g01n015/06).ipc. or (73/28.01 or 73/865.5 or 73/28.04).ccls.)	USPAT	OR	ON	2005/11/13 23:55
L25	12	((timer or timing) near5 (control or controlled or controlling) near5 (sample or sampler or sampling or sampled or specimen)) and exhaust	US-PGPUB	OR	ON	2005/11/13 23:55
L26	4	((timer or timing) near5 (control or controlled or controlling) near5 (sample or sampler or sampling or sampled or specimen)) same exhaust	US-PGPUB	OR	ON	2005/11/13 23:57
L27	26	((timer or timing) near5 (control or controlled or controlling) near5 (sample or sampler or sampling or sampled or specimen)) same exhaust	USPAT	OR	ON	2005/11/13 23:58
L28	816	(438/5 or 438/14).ccls. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57 or 73/28.01 or 73/28.04 or 73/865.5).ccls.	US-PGPUB	OR	ON	2005/11/14 00:03
L29	133	(438/5 or 438/14).ccls. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57 or 73/28.01 or 73/28.04 or 73/865.5).ccls.	EPO	OR	ON	2005/11/14 00:03

L30	712	(438/5 or 438/14).ccls. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57 or 73/28.01 or 73/28.04 or 73/865.5).ccls.	JPO	OR	ON	2005/11/14 00:03
L31	3281	(438/5 or 438/14).ccls. or (73/863.01 or 73/863.23 or 73/863.86 or 73/863.57 or 73/28.01 or 73/28.04 or 73/865.5).ccls.	USPAT	OR	ON	2005/11/14 00:03